

NOV 09 2004

OKI.557

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Takeshi Morita

Examiner: Unknown

Serial No.: 10/627,734

Attorney Docket No.: OKI.557

Filed: July 28, 2003

Confirm. No.: 3806

For: METHOD FOR ESTIMATING REMAINING FILM THICKNESS DISTRIBUTION,
METHOD FOR DESIGNING PATTERNING MASK USING THE METHOD FOR
ESTIMATING REMAINING FILM THICKNESS DISTRIBUTION, AND METHOD
FOR MANUFACTURING SEMICONDUCTOR DEVICES BY USING
PATTERNING MASK DESIGNED BY USING THE METHOD FOR ESTIMATING
REMAINING FILM THICKNESS DISTRIBUTION

CLAIM OF PRIORITY

U.S. Patents and Trademark Office
2011 South Clark Place
Crystal Plaza Two, Mail Stop
Arlington, VA 22202

Date: March 22, 2004

Sir:

Applicant, in the above-identified application, hereby claims the priority date
under the International Convention of the following Japanese application:

Appln. No. 2001-219979

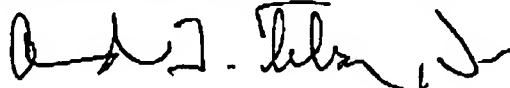
filed July 29, 2002

as acknowledged in the Declaration of the subject application.

A certified copy of said application is being submitted herewith.

Respectfully submitted,

VOLENTINE FRANCOS, P.L.L.C.



Andrew J. Telesz, Jr.
Registration No. 33,581

Tel. (703) 715-0870
Fax. (703) 715-0877

日本国特許庁
JAPAN PATENT OFFICE

別紙添付の書類に記載されている事項は下記の出願書類に記載されて
いる事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed
with this Office.

出願年月日
Date of Application: 2002年 7月29日

出願番号
Application Number: 特願2002-219979

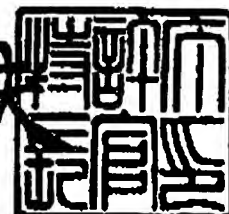
(ST. 10/C): [JP2002-219979]

願人
Applicant(s): 沖電気工業株式会社

2003年 8月21日

特許庁長官
Commissioner,
Japan Patent Office

今井康夫



ATTY DOCKET #: OKI.557

APPLICANT: Takeshi Morita

DUE DATE:

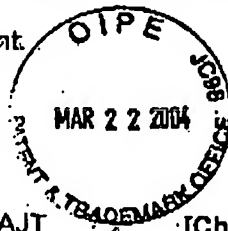
SERIAL NO.: 10/627,734

FILING DATE: July 28, 2003

TITLE: METHOD FOR ESTIMATING REMAINING FILM THICKNESS
DISTRIBUTION. METHOD FOR DESIGNING PATTERNING
MASK...

RECEIPT OF THE FOLLOWING PAPERS IS ACKNOWLEDGED:

Claim of Priority Letter, and Priority Document.



DATE: March 22, 2004

ATTY: AJT

[Check No. n/a]